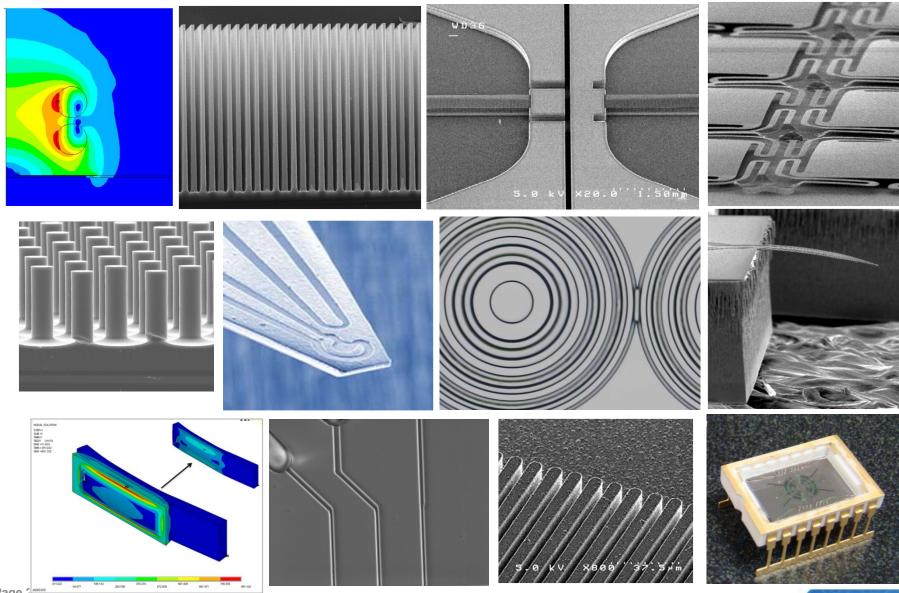
# **AMFitzgerald Company Overview**

**July 2014** 





## Mission: Your Partner in MEMS Product Development



### **Company background**

- Founded 2003 by Alissa M. Fitzgerald, self-funded
- Burlingame, CA: near SFO and Silicon Valley
- Goal: to be the premier MEMS product development firm
- Consistent growth
  - Over 125 clients served to date
- Active member of the MEMS Industry Group



Headquarters in Burlingame, CA

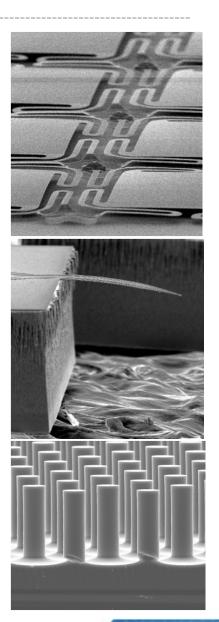


Fab operations at 1500m<sup>2</sup> UCBerkeley Marvell Nanolab



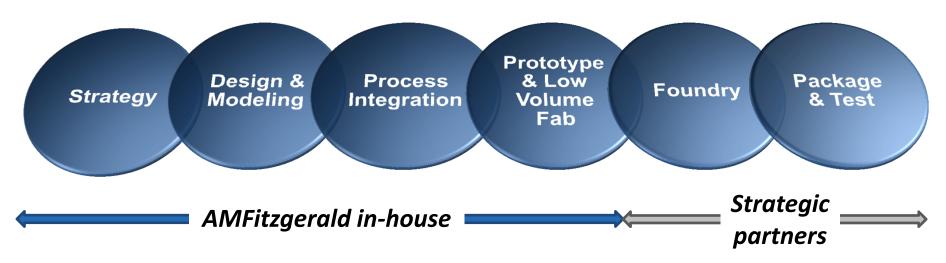
### **Our value**

- First time developing MEMS?
  - We can provide a complete solution
- Improving your MEMS product?
  - Let us optimize your design
- Investing in MEMS?
  - Valuable insight from expert practitioners
- Our competitive advantage
  - A complete MEMS solution
  - Expert design and process engineers





### A complete supply chain from concept to production



- Multi-disciplinary, expert engineering team
- Custom MEMS development from start to finish
- Design and process integration for volume production
- In-house prototype fabrication, easy transition to production partners

### **Production solutions**

#### A menu to satisfy different customer needs

Full custom low volume



Open search for foundry partner

Full custom high volume

Open search for foundry partner

Fast time to market with foundry-specific design



Faster time to market with semi-custom sensors



Fastest time to market with standardized 200mm process



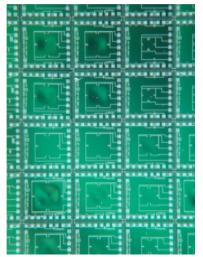
**Process flexibility** 

**Speed to market** 



### AMFitzgerald's RocketMEMS<sup>TM</sup>: Semi-custom sensors

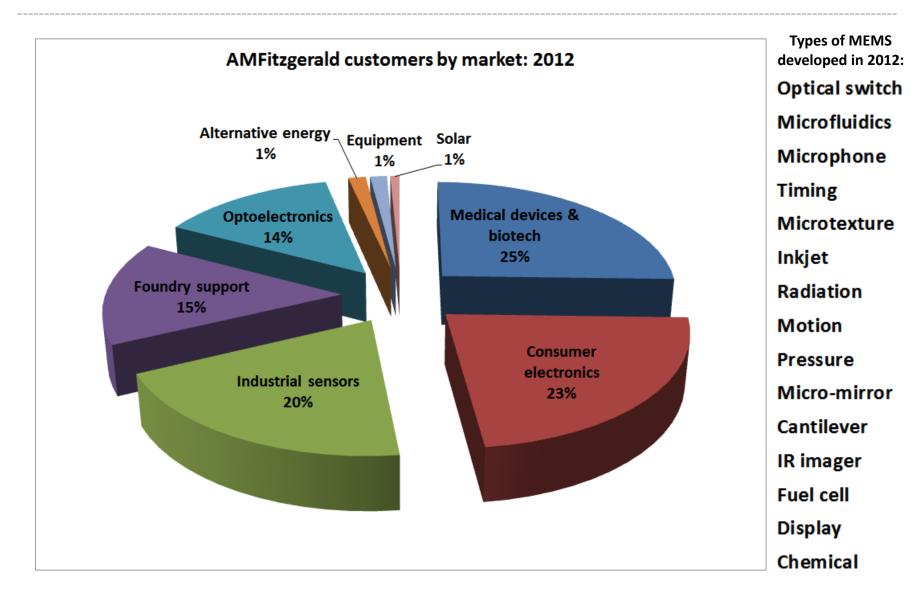




Variety of RocketMEMS Pressure Sensors

- MEMS solutions for OEMs and system integrators
  - AMFitzgerald reference designs
  - ISO-certified foundries
  - Cost-effective multi project wafer runs
- 1. Customer provides desired sensor specification
- 2. AMFitzgerald tailors reference design to meet customer's spec
- 3. Silex manufactures wafers
- 4. AMFitzgerald tests and delivers sensors to customer

#### Our diverse customer base



### **MEMS** type core competencies

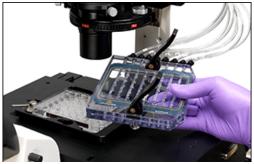
### Sensor types

- Motion, pressure, acoustic, infrared, magnetic, radiation, resonators, chemical
- Transduction principles
  - Piezoresistive, piezoelectric, electrostatic, capacitive
- Actuators
  - Electrostatic, piezoelectric
- Microfluidics
- Micromolds and surface texturing

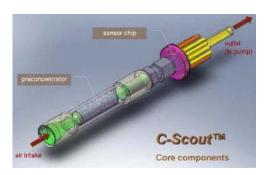
#### **AMFitzgerald Client Products**



Cantimer OSMO Dehydration Sensor



Fluxion Biosciences BioFlux product

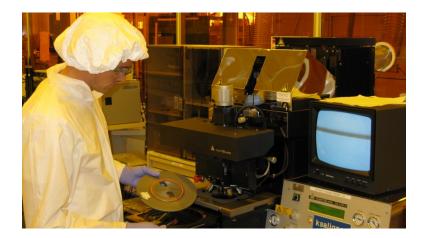


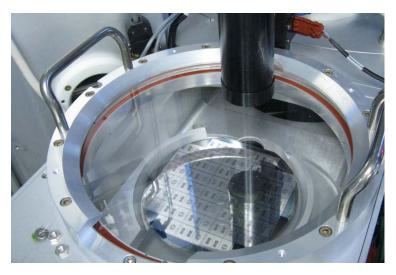
NNTS C-Scout product



### **MEMS** process core competencies

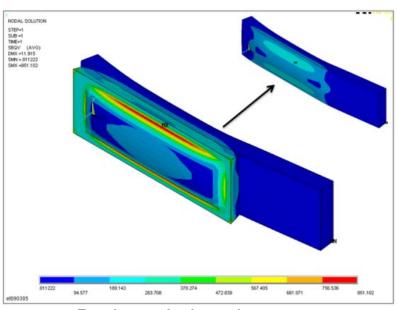
- All MEMS process techniques
- Process specialties:
  - Thick lithography
  - High aspect ratio silicon etch
  - Sacrificial release by vapor HF or XeF2
  - Aluminum nitride and other new materials
  - Silex Sil-Via TSV
  - Laser and abrasive drilling
  - Stealth dicing
- Managing risk and uncertainty of MEMS R&D



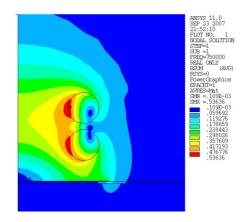


### **MEMS** design core competencies

- ANSYS Multiphysics
- Tanner EDA L-Edit
- SoftMEMS
- Matlab
- Proprietary fracture prediction
- Intelligent use of simulation to minimize risk and reduce fab cycles
  - Management of uncertainty in MEMS material properties



Package-induced stresses



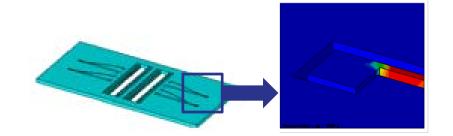
Magnetic field of inductor coils



### Case studies: Design and process integration

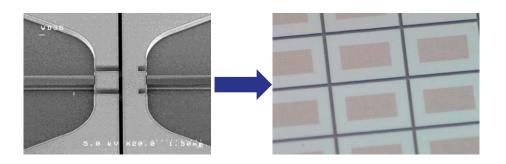
#### Accelerometer:

- Design to specification
- Fabrication on the InvenSense NF Shuttle



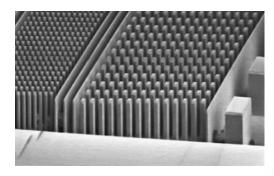
### Microfluidic pump:

- Redesign to lower cost of fabrication
- Prototype, then foundry transfer



### Process improvement:

 Improved DRIE aspect ratio from 20:1 to 46:1 on existing toolset



### Case study: From concept to manufacturing

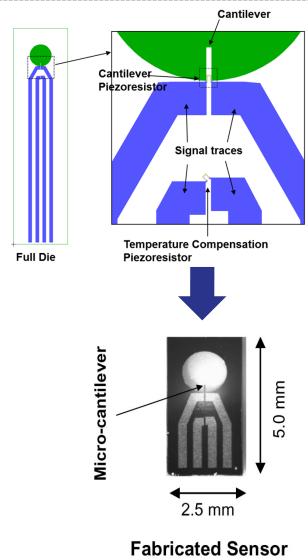
### Cantimer dehydration sensor

### Development

- First prototypes functional (7 layer process)
- Piezoresistor value matched simulation

### Foundry Transfer

- Bidding and diligence process with five foundries
- Die shrink
- Transfer of AMFitzgerald prototype enabled > 90% yield on the first run



Fabricated Sensor (Viewed From Above)

### **Business process: custom R&D**

- Initial meeting: fit and scope of work
- Detailed project plan and cost proposal provided
- Project performed in discrete Phases to minimize risk
  - Phase 1: Design exploration
  - Phase 2: Prototype fabrication 1
  - Phase 3: Test and design iteration
  - Phase 4: Prototype fabrication 2
  - Etc.
- Collaborative interactions
- Client owns all work product and intellectual property
  - Including masks and runsheets, which will be transferred to foundries



### The secrets to MEMS development success

- Have adequate funds and timeline for multiple prototype iterations
- Robust designs do not push process tolerances
- Bring only mature prototypes to foundry

### **Public client list (partial)**

## Startups and Small-Medium Businesses:

**Advanced Diamond Technologies** 

**Bay Materials LLC** 

**CPAC** 

Cantimer, Inc.

Edge Embossing LLC

**Endotronix** 

Fluxion Biosciences

Hepregen

Microfabrica

Micralyne

NovaSpectra

PolyOptic Technologies

SemQuest

Silicon Light Machines

Silicon Microstructures

**Tactus Technologies** 

Wave 80 Biosciences

Yole Développment

#### **Public Companies:**

**Agilent Technologies** 

**Applied Materials** 

Caliper LifeSciences

Cypress Semiconductor

Maxim Integrated

Measurement Specialties

Micrel

Mirion

Panasonic ACOM-TC

Sorin

Symmetricom

**Ricoh Innovations** 

#### **Research Institutions:**

Alfred E. Mann Foundation

DARPA

MIT

Stanford University

Stowers Institute

UCSF, Opthalmology

Weill Medical College of Cornell Univ.

### **Company contact information**

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